



Docket No.: Z&PINFP08190

#17/IDS
3/9/84

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 09/904,360 Confirmation No.: 1413
Inventor : Giuseppe Curello et al.
Filed : July 12, 2001
Title : Process for Producing a Doped Semiconductor Substrate
TC/A.U. : 2825
Examiner : Igwe U. Anya
Customer No.: 24131

Hon. Commissioner for Patents
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. 1.97(b)(4)

Sir:

In accordance with 37 C.F.R. 1.97(b)(4), a copy of the following U.S. patent is submitted herewith:

U.S. Patent No. 5,296,388 (Kameyama et al.), dated March 22, 1994.

Respectfully submitted,

For Applicants

WERNER H. STEMER
REG. NO. 34,956

Date: February 5, 2004

Lerner And Greenberg, P.A.
Post Office Box 2480
Hollywood, FL 33022-2480
Tel: (954) 925-1100
Fax: (954) 925-1101
/bb